

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/239,659	DYE ET AL.	
Examiner	Art Unit	
Hong C. Kim	2185	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
Sec Aff.	sch	10/11/06	(K		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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